



JFW

PATENT
Docket No. 20067/OPP031475

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant(s): PARK, Geon-Ook

Serial No.: 10/748,652

Filed: December 30, 2003

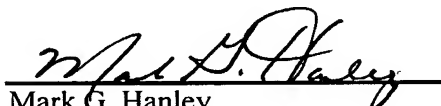
For: "Method of Forming a Trench in a
Semiconductor Device"

Group Art Unit: 2812

Examiner: Not Yet Assigned

) I hereby certify that this paper is
) being deposited with the United
) States Postal Service with
) sufficient postage as first class
) mail in an envelope addressed to:
) Commissioner for Patents, P.O.
) Box 1450, Alexandria, VA 22313-
) 1450 on this date:

) **August 16, 2005**

) 
) Mark G. Hanley
) Registration No. 44,736
) Attorney for Applicant(s)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The document listed on the enclosed PTO Form-1449 is submitted pursuant to 37

CFR §§ 1.56, 1.97, and 1.98. A copy of the document is enclosed.

TIME OF FILING

This information disclosure statement is being filed to the best of the undersigned's knowledge, before the mailing date of a first Office action on the merits. In accordance with 37 CFR §1.97(b), no certification or fee is required.

METHOD OF PAYMENT

No fee is required.

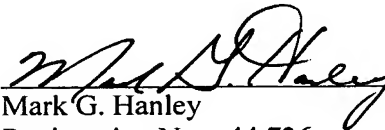
The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 50-2455. A copy of this paper is enclosed.

Correspondence Address:

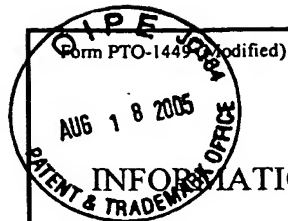
Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC.
USPTO Customer Number 34431
20 N. Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

By:


Mark G. Hanley
Registration No.: 44,736

August 16, 2005



U.S. Department of Commerce
Patent and Trademark Office

Atty. Docket No.

20067/OPP031475

Serial No.

10/748,652

Applicant

PARK

Filing Date

December 30, 2003

Group Art Unit

2812

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

FOREIGN PATENT DOCUMENTS

*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No
	B01	1998-026303	07/15/1998	Korea			Abstract Only	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.